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	Filing Date		2006-05-18	
	First Named Inventor	Hans-Joachim Lewerenz		
	Art Unit	1795		
	Examiner Name	Not Yet Assigned		
	Attorney Docket Number	21141/0213299-US0		

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4	61292381	JP	A	1986-12-23	Sharp Kk	English Abstract	<input type="checkbox"/>
5	102008004340	DE	A1	2009-07-16	Helmholtz Zentrum Berlin Fuer	Corresponds to cite no. 6 under Foreign Patent Documents	<input type="checkbox"/>
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	2	GREEN MAET AL: "20% EFFICIENT LASER GROOVED, BURIED CONTACT SILICON SOLAR CELLS" PHOTOVOLTAIC SPECIALISTS CONFERENCE. LAS VEGAS, SEPT. 26 - 30, 1988, NEW YORK, IEEE, US, Bd. VOL. 1 CONF. 20, 26. September 1988 (1988-09-26), Pages 411-414, XP000166680	<input type="checkbox"/>
	3	JENSEN J AD ET AL: "ELECTROCHEMICAL DEPOSITION OF BURIED CONTACTS IN HIGH-EFFICIENCY CRYSTALLINE SILICON HOTOVOLTAIC CELLS" JOURNAL OF THE ELECTROCHEMICAL SOCIETY, Vol. 150, No. 1, January 2003 (2003-01), pages 49-G57, XPOOI090500	<input type="checkbox"/>
	4	VETTIGER P ET AL: "THE MILLIPEDE-NANOTECHNOLOGY ENTERING DATA STORAGE" IEEE TRANSACTIONS ON NANOTECHNOLOGY, Vol. 1, No. 1, March 2002 (2002-03), pages 39-55.	<input type="checkbox"/>
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